

Publikationen

(2016): Deflectometric Acquisition of Large Optical Surfaces “ DaOS” Using a New Physical Measurement Principle: Vignetting Field Stop. (Reprinted from Proceedings of SPIE Volume 10009: Third European Seminar on Precision Optics Manufacturing, 100090Y [Teisnach, April 12th 2016] doi:10.1117/12.2236134). In: Bavarian Journal of Applied Sciences, no. 2, pp. 146-161.

(2016): Deflectometric acquisition of large optical surfaces (DaOS) using a new physical measurement principle: vignetting field stop procedure. In: Proceedings of SPIE 10009 (Third European Seminar on Precision Optics Manufacturing, 100090Y [April 12th 2016, Teisnach]). DOI: 10.1117/12.2236134.

(2015): The vignetting field stop procedure: A new physical measurement principle for the Deflectometric acquisition of big Optical Surfaces - DaOS. In: DGaO Proceedings (116. Jahrestagung in Brno, Tschechische Republik, 25.-29.05.2015).